



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 19, 2025

IGI Report Number **LG758521091**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.61 - 8.68 X 5.30 MM**

GRADING RESULTS

Carat Weight **2.46 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

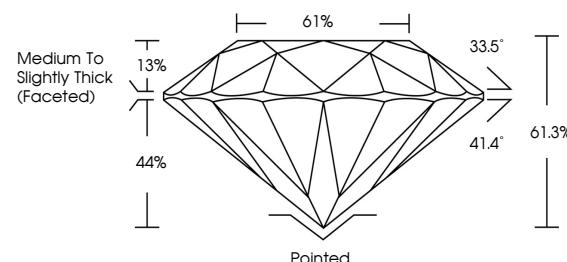
IGI **LG758521091**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

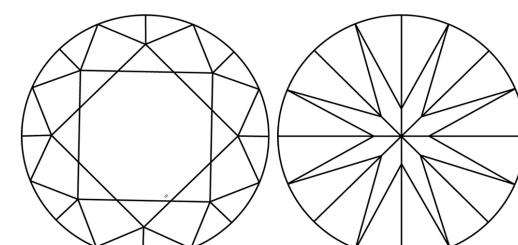
Type Ila

LG758521091
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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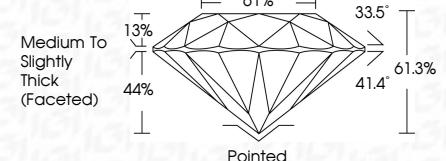
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Sample Image Used



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December 19, 2025	IGI Report No LG758521091	ROUND BRILLIANT	2.46 CARATS	E	VS 1	EXCELLENT	61.3%	61.3%	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG758521091
Carat Weight	8.61 - 8.68 X 5.30 MM	Color Grade	Color Grade	Clarity Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Medium to Slightly Thick (Faceted)	Pointed	Excellent	None
Clarity Grade		Fluorescence		Inscription(s)									
Cut Grade		Inscription(s)											
Depth													
Table													
Girdle													

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